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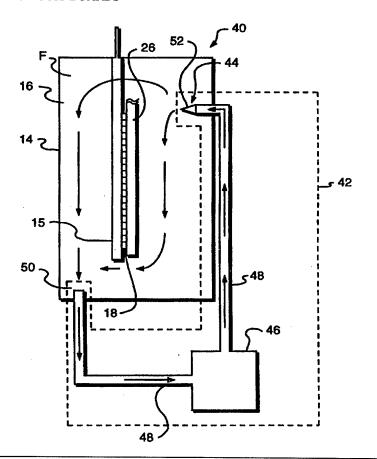
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Before the expiration of the time limit for amending the claims and to be republished in the event of the receipt of amendments.

(54) Title: UNIFORM ELECTROPLATING OF PRINTED CIRCUIT BOARDS

(57) Abstract

A method and apparatus for the uniform electroplating of printed circuit boards is described. In one embodiment of the present invention, selected areas of the electroactive surface of the anode (15) or cathode electrode (26) are covered with a mask (18), whereby to establish substantially uniform electroplating ion transfer over the target areas of the target cathode (26).



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1 UNIFORM ELECTROPLATING OF PRINTED CIRCUIT BOARDS 2 This invention relates to electroplating or electro-3 deposition of metal on a target. The invention has 4 particular utility in connection with electro-deposition 5 of metal onto printed circuit boards or panels and will be described in connection with such utility, although other 7 utilities are contemplated. 8 9 Electroplating is an established process of producing a metallic coating on a surface. Such coatings may 10 11 perform a protective function to prevent corrosion of the metal on which they are deposited, e.g., plating with zinc 12 13 or tin (electro-galvanizing); or a decorative function, 14 e.g., gold or silver plating; or both functions, e.g., 15 chromium plating. 16 The principal of electroplating is that the coating 17 metal is deposited from an electrolyte, typically an 18 aqueous acid or alkaline solution, onto a target substrate 19 or panel. The latter forms the cathode (negative electrode) while a plate of the metal to be deposited 20 21 serves as the anode (positive electrode). Alternatively, 22 the anode may be made of an electrochemically inert (that is, not subject to decomposition during electroplating) 23 metal and the plating metal may be deposited onto the 24 25 cathode solely from the electrolytic solution. 26 Usually, the cathode is coated with an industry 27 standard resist material to prevent plating of those areas of the cathode covered with the resist. After plating of 28 29 the cathode, the resist pattern is removed, thereby leaving unplated the areas of the cathode that had been 30 covered with the resist. As will be appreciated, such 31 conventional resist patterns are incapable of solving the 32 problems with which the present invention is concerned. 33 During a standard electroplating process, the 34 periphery of the printed circuit board, i.e., the portions 35

of the printed circuit board adjacent its outer edges,

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l tends to be at a higher current density than the center of

- 2 the printed circuit board. Hence, metal deposits more
- 3 rapidly adjacent the periphery of the printed circuit
- 4 board than at the center. The result of this is that by
- 5 the time the metal has deposited at the center of the
- 6 circuit board to form a desired thickness, the metal
- 7 deposited adjacent the periphery is at a thickness much
- B greater than the thickness at the center. As a result,
- 9 the width of depositing metal lines may grow laterally,
- 10 and the resulting plated lines near the periphery may
- ll develop a cross sectional configuration resembling a
- 12 mushroom.

In U.S. Patent No. 4,828,654, it is reported that by

14 spacing the cathode a relatively large distance from the

15 anode, and by making the effective size of the panel to be

16 plated, i.e. the cathode, larger in size than the anode,

17 there is more uniform distribution of the electroplating

18 field. The more uniformly distributed field causes the

19 metallic ions to be electrolytically deposited at a more

20 uniform rate over the articles in the panel. This prior

21 art arrangement reportedly avoids undesirable uneven

22 plating build-up on the articles at those areas where

23 there is a concentration of the electroplating field. It

24 is also reported that field concentrations occur when the

25 size of the article is smaller than the size of the anode,

26 and results in the edges of the article experiencing a

27 substantially greater build up of metallic ions than the

28 center area of the article. Making the effective size of

29 the cathode (the article to be plated) greater than the

30 size of the anode and spacing the anode a relatively large

31 distance from the cathode, operates to discourage the

32 formation of areas of concentration in the electroplating

33 field and encourages the ion transfer to become more

34 uniform over the entire area of the cathode.

35 U.S. Patent No. 4,828,654 teaches an anode used in

36 electroplating formed by a plurality of individual anode

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1 segments which can be selectively energized to establish 2 an effective anode size that relates to the size of the article to be electroplated, thereby establishing an 3 electrical field of more uniform characteristics to 4 transfer ions from the anode to the articles at a more 5 uniform deposition rate over the whole surface of the article. By adjusting the effective size of the anode to 7 correspond and relate to the size of the article, the non-8 uniform deposition rates associated with concentrated 9 localized field reportedly are avoided, and the physical 10 11 size of the electroplating apparatus can be reduced. 12 U.S. Patent No. 4,933,061 teaches an electroplating 13 apparatus for electroplating a plurality of items. 14 patented apparatus includes a tank having a bottom wall 15 and side walls, adapted to hold a predetermined quantity of electrolytic plating solution. A sparger system at the 16 17 bottom of the tank directs the electrolytic plating solution in an upward direction. A cathode rack supports 18 19 the items to be electroplated and extends intermediate to 20 the anode plates and upwardly from the sparger system. 21 Strategically placed openings in the anodes and an anode 22 screen in conjunction with the sparger system reportedly 23 act to reduce the plating thickness variance over the 24 rack. 25 In U.S. Patent No. 5,017,275, there is disclosed an 26 anode structure comprising a resilient anode sheet having 27 an active anode surface, and a support sub-structure for The anode sub-structure has a pre-28 the anode sheet. 29 determined configuration. By flexing the anode sheet onto the anode sub-structure, so that the anode sheet conforms 30 31 to the configuration of the anode sub-structure, there 32 reportedly is provided an adequate electrical junction for substantially uniform current distribution. 33 A collection of the known variables which affect the 34

electroplating process have been set out in detail in the

HANDBOOK OF PRINTED CIRCUIT MANUFACTURING by Raymond H.

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- 1 Clark (1985). Therein it is reported that the factors
- 2 which effect the electroplating process include:
- 3 l. plating pattern geography;
- 4 2. panel thickness and size of plated through holes;
- 5 3. panel boarders;
- 6 4. plating rack;
- 5. bath chemistry, e.g., concentration of metals
- 8 and acids, concentration of organic leveling and
- 9 brightening agents, concentration of contaminants;
- 10 6. bath temperature;
- 11 7. anode-cathode spacing;
- 12 8. anode current density;
- 9. anode depletion;
- 14 10. plating bath agitation;
- 15 ll. cathode agitation;
- 16 12. rectifier consideration; and
- 17 13. the skill and experience of the plater.
- 18 The present invention provides an improved
- 19 electroplating system which overcomes the aforesaid and
- 20 other problems of the prior art which have resulted in
- 21 less than uniform electroplating and metallic deposition,
- 22 and in so doing provides substantially uniform
- 23 distribution of the deposited metal, from item to item in
- 24 an electroplating process.
- In accordance with the present invention, a system for
- 26 electroplating comprises a receptacle for holding a bath
- 27 of electroplating solution. An electrically conducting
- 28 anode electrode is positioned within the receptacle in
- 29 contact with the bath. In one preferred embodiment, the
- 30 anode is covered at least in part with one or more
- 31 electrically non-conductive masks which operate to direct
- 32 the electric current as it travels through the
- 33 electroplating solution to distribute over the cross-
- 34 sectional surface area of a conductive substrate immersed
- 35 in the electroplating receptacle at a location spaced
- 36 apart from the anode to establish substantially uniform

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- 1 electroplating ion transfer over the surface of the
- 2 substrate. The mask or masks may be in direct contact
- 3 with the anode, or in close proximity thereto. Completing
- 4 the system are means for electrically energizing the anode
- 5 and completing the circuit to the target/cathode.
- 6 The overall size of the anode, and the size and shape
- 7 of the mask or masks, mask openings, number of openings,
- 8 and location of openings in the non-conductive mask are
- 9 all selected with reference to the size, target
- 10 configuration and aspect ratio (anode-to-target) of the
- ll article to be electroplated. The distance separating the
- 12 masked anode from the target panel substrate also is
- 13 adjusted to promote uniform targeting of the
- 14 electroplating current.
- 15 The present invention also provides a method of
- 16 electroplating an article with a generally uniform
- 17 thickness coating. In one preferred embodiment, this
- 18 method comprises covering the anode electrode at least in
- 19 part with one or more electrically non-conductive masks
- 20 having a pattern of openings of predetermined
- 21 configuration relative to the target cathode whereby to
- 22 result in substantially uniform deposition over the target
- 23 during electroplating.
- 24 Further features and advantages of the present
- 25 invention will be apparent from the following detailed
- 26 description of the invention taken in conjunction with the
- 27 drawings, wherein like numerals depict like parts, and
- 28 wherein:
- 29 Figure 1 is a perspective view of an electroplating
- 30 apparatus embodying the present invention;
- 31 Figure 2 is a side view of portions of the
- 32 electroplating system of Figure 1; and
- Figure 3 is a view similar to 2, and illustrating an
- 34 alternative form of electroplating system made in
- 35 accordance with the subject invention;

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1 Figure 4 is a side view of portions of another 2 preferred embodiment of an apparatus embodying the present 3 invention; 4 Figure 5 is a side view of portions of a variant of 5 the embodiment of Figure 4; 6 Figure 6 is a side view of portions of a further 7 variation of the embodiment of Figure 4; and 8 Figure 7 is a partial side-elevational view of an 9 alternative anode construction for use in the embodiments 10 of Figures 4-6. 11 Referring to Figures 1 and 2, one embodiment 10 of an 12 electroplating system according to the present invention 13 is illustrated. System 10 includes an outer housing 12 14 which is preferably formed of an electrically insulating 15 and corrosion-resistant material such as plastic. 16 housing 12 includes means in the form of a downward 17 extending receptacle 14 for holding a bath of an 18 electroplating solution 16. By way of example, for 19 electroplating copper, bath 16 may comprise a copper 20 sulfate solution commonly referred to as "acid copper". 21 The plastic material of the housing 12 and receptacle 14 22 resists the toxic and corrosive effects of the bath 16. 23 The electroplating system 10 includes an anode 24 electrode 15 which preferably is covered at least in part 25 with a non-conductive mask 18 (Figure 2), which will be 26 described in detail below. Mask 18 may be coated directly 27 on the electro-active surface of anode electrode 15 or may 28 comprise a separate element which may be fixed to or 29 suspended in close proximity to the electro-active surface 30 of electrode 15. The anode electrode 15 and mask 18 are 31 suspended from an upper support member 20 which is 32 preferably formed of plastic to resist the corrosive 33 effects of the bath 16 and to provide electrical 34 insulation. The anode electrode 15 and mask 18 are held

suspended from the support member 20 by fasteners such as

non-corrosive titanium machine screw 22.

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1 The article to be plated typically comprises a printed circuit board 26 which becomes the electrical cathode of 2 the electroplating system during electroplating. 3 printed circuit board 26, which may be covered with an 4 industry standard resist material (not shown), is suspended in the bath by a clamp 28 which includes a 6 thumbscrew 30 or other similar fastening device for 7 8 attaching and suspending or supporting the article to be electroplated in the bath. Clamp 28 in turn is 9 mechanically connected to an electrically insulating 10 support member 34. A handle 36 extends above the support 11 member to allow the printed circuit board to be inserted 12 into and removed from the bath 16 at the start and end of 13 14 the electroplating process. Completing the system are electrical conductors 29 and 15 16 32 for electrically connecting the anode electrode 15 and 17 cathode target 26 to a direct current or quasi direct 18 current electrical energy source 38. 19 A feature and advantage of the present invention is 20 the ability to substantially and uniformly electroplate the conductor paths, lands and holes of a target printed 21 22 circuit board. Preferably, this is accomplished by 23 covering selected areas of the electro-active surface of a solid anode 15 with a non-conductive mask 18 which directs 24 25 the electric current through the electroplating solution so that the metal will be deposited onto the target 26 cathode in a controlled (that is, in a substantially 27 uniform) manner. The overall size of the anode, and the 28 size and shape of the openings, number of openings, and 29 30 location of the openings in the non-conductive mask are selected with reference to the size and geometry of the 31 target article to be electroplated, with the result that 32 field concentrations at any location on the target article 33 34 are avoided, thereby achieving a relatively uniform layer of electroplated material. 35

Typically, the mask generally will have openings which

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- 1 are substantially the negative of the target article.
- 2 However, in order to compensate for uneven plating buildup
- 3 on the target panel periphery, the mask openings
- 4 corresponding to peripheral areas of the target board
- 5 preferably should be made relatively smaller than
- 6 corresponding deposition areas on edges of the target
- 7 board, while the mask openings corresponding to center
- 8 areas of the target board preferably should be made
- 9 relatively larger than the corresponding deposition areas
- 10 on center areas of the target board. Mask size and shape
- 11 may be empirically determined using the above criteria.
- 12 The mask may be applied directly to the anode electro-
- 13 active surface, for example, by coating, or the mask may
- 14 comprise a separate element which may be fixed directly to
- 15 or held in close proximity to the anode electro-active
- 16 surface, thereby allowing various selected exposed
- 17 portions of the anode to serve as a source of field
- 18 concentration for the electroplating process.
- 19 The distance between the masked anode and the target
- 20 printed circuit board should be limited to a relatively
- 21 short distance, typically 2 to 3.5 inches at normal
- 22 plating potentials, so that bulk transfer through the
- 23 electroplating bath does not defeat the masking effect.
- 24 Certain changes may be made in the above constructions
- 25 without departing from the spirit and scope of the
- 26 invention. For example, as shown in Figure 3, it also is
- 27 possible to achieve uniform deposition by covering the
- 28 cathode with one or more non-conductive apertured masks.
- 29 In such case, the mask or masks should be spaced a short
- 30 distance, e.g. 1.75 to 3 inches from the cathode.
- 31 Locating the mask less than 1.75 inches or more than 3
- 32 inches from the cathode is not advised and may not achieve
- 33 uniform deposition.
- 34 Other modifications are also possible. For example,
- 35 as shown in Figure 4, in another preferred embodiment 40
- 36 of the present invention similar to that shown in Figures

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- 1 1-2, the anode 15 is placed in direct contact with mask 18
- 2 which is placed in direct contact with cathode 26.
- 3 Embodiment 40 also includes electrolyte circulation means
- 4 42 (shown in dashed lines) which permits controlled
- 5 circulation or flow F of electrolyte fluid 16 in bath
- 6 receptacle 14. Circulation means 42 comprises at least
- 7 one conventional nozzle means 44 connected to a
- 8 conventional filtered pump 46 which pumps fluid 16 from
- 9 bath 14 through pipe means 48 (via opening 50 in
- 10 receptacle 14) to nozzle 44, and thence, back into
- 11 receptacle 14. Preferably, nozzle means 44 comprises a
- 12 conventional shuttered aperture 52 for controllably
- 13 adjusting direction and magnitude of fluid flow from
- 14 nozzle 44. Advantageously, by appropriately adjusting
- 15 direction and velocity of the flow of fluid in bath 14,
- 16 the uniformity and speed of deposition of electroplating
- 17 material upon cathode 26 may be increased.
- Figure 5 shows a variation 60 of the embodiment 40 of
- 19 Figure 4, in which variation 60 circulating means 42
- 20 comprises a plurality of nozzle means 44A . . . 44J
- 21 configured into two oppositely facing banks 62A, 62B of
- 22 nozzles on opposite sides of board 26. In this embodiment
- 23 60, the nozzles 44A . . . 44J are connected to a common
- 24 combination pressure manifold and circulatory pump 46.
- 25 Of course, each of the nozzles 44A . . . 44J or any number
- 26 of them may be connected to independent pumps and/or
- 27 pressure manifolds (not shown), without departing from the
- 28 present invention. Additionally, although only two banks
- 29 of five nozzles each are shown in Figure 5, it will be
- 30 appreciated that the number and configuration of nozzles
- 31 may be varied without departing from this embodiment 60 of
- 32 the present invention.
- 33 Various other modifications are also possible without
- 34 departing from the present invention. For example, the
- 35 nozzles 44A . . . 44J of embodiment 60 of Figure 5 may
- 36 comprise respective conventional shuttered-apertures.

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- 1 Additionally, as shown in Figure 6, the embodiments shown
- 2 in Figures 4 and 5 may comprise conventional controllable
- 3 electromotive means 64A . . . L connected to circulation
- 4 means 42 to permit the nozzles to move within bath 14.
- 5 Preferably, electromotive means 64A . . . L are controlled
- 6 via conventional programmable controller device 66 to move
- 7 the nozzles according to a predetermined pattern to
- 8 improve deposition of electroplating material upon cathode
- 9 26 by providing appropriate flow F of electrolyte fluid in
- 10 the bath.
- 11 Also alternatively, the embodiments shown in Figures
- 12 4-6 may comprise an alternative anode 15A shown in Figure
- 13 7. Anode 15A (which preferably is made of an
- 14 electrochemically inert material) may be used by itself
- 15 (i.e., without necessitating use of a mask) to accomplish
- 16 substantially uniform electroplate ion transfer onto the
- 17 target cathode. Preferably, anode 15A comprises a
- 18 metallic, fine wire mesh grid 74 having a plurality of
- 19 relatively small openings (representatively referred to by
- 20 numeral 72). The dimensions of the openings 72 of grid
- 21 anode 15A are empirically determined so as to permit
- 22 substantially uniform electroplate ion transfer onto
- 23 cathode 26. Preferably, when alternative anode 15A is
- 24 substituted into the embodiments of Figures 4-6, the anode
- 25 15A and cathode 26 are separated from each other by a
- 26 distance much smaller than 2 to 3.5 inches; preferably,
- 27 this distance is made such that the anode and cathode
- 28 almost contact each other. Alternatively, anode 15A may
- 29 be placed in direct contact with industry standard plating
- 30 resist on cathode 26.
- 31 Additionally, the industry standard plating resist
- 32 pattern usually placed on cathode 26 prior to the
- 33 electroplating process may be adjusted using computer
- 34 simulation techniques so as to aid the mask 18 and/or
- 35 anode 15A in establishing uniform electroplate ion
- 36 transfer according to the present invention.

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- Other modifications may also be possible. It is
- 2 accordingly intended that all matter contained in the
- 3 above description or shown in the accompanying drawings
- 4 shall be interpreted as illustrative and not in a limiting
- 5 sense.

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1	CLAIMS
2	
3	 In an apparatus for electroplating a target
4	cathode, said apparatus including an anode electrode
5	having an electroactive surface in contact with
6	electrolytic fluid of an electroplating bath, the
7	improvement which comprises at least one electrically non-
8	conductive apertured mask in direct contact with and
9	covering said cathode at least in part whereby to direct
10	electric current through the electroplating solution in a
11	controlled manner onto the target cathode, said anode
12	being placed in direct contact with said mask (26) on said
13	cathode, and means (46) for controllably circulating said
14	fluid of said bath.
15	2. In an apparatus according to claim 1, the
16	improvement characterized by one or more of the following
17	features:
18	(a) said circulating means comprises at least
19	one nozzle means (44) for directing flow of said
20	circulating fluid in said bath;
21	(b) said cathode is interposed between banks of
22	facing nozzle means (44A) for directing flow of said
23	circulating fluid in said bath;
24	(c) said circulating means comprises at least
25	one nozzle means (44A) having adjustable shutter
26	means for changeably directing flow of said circulating
27	fluid in said bath;
28	(d) said at least one mask (15A) comprises a
29	plurality of openings (72) which are adjusted to establish
30	substantially uniform electroplate ion transfer onto the
31	target cathode;
32	(e) said cathode is interposed between two banks
33	of oppositely facing nozzle means (44A) having
34	adjustable shutter means for changeably directing flow of
35	said circulating fluid in said bath; and wherein said
36	circulation means preferably comprises at least one pozzle

- 1 means and electromotive means (64A \dots) for controllably
- 2 moving said nozzle means;
- 3 (f) said circulation means comprises a plurality
- 4 of nozzles connected to a combination pump (64) and
- 5 manifold for circulating said fluid of said bath, and
- 6 wherein at least one additional mask preferably is
- 7 interposed between said anode and said at least one mask
- 8 of said cathode, said circulation means preferably
- 9 comprises controllable electromotive means (64A . . .) for
- 10 controllably moving said nozzle means, and said nozzle
- 11 means (44A . . .) preferably has shutter means for
- 12 changeably directing flow of said circulating fluid in
- 13 said bath; and
- 14 (g) said cathode comprises a conventional resist
- 15 pattern disposed thereon, which pattern is adjusted to aid
- 16 said at least one mask in establishing substantially
- 17 uniform electroplate ion transfer to said cathode.
- 18 3. In an apparatus for electroplating a target
- 19 cathode, said apparatus including an anode electrode
- 20 having an electroactive surface in contact with
- 21 electrolytic fluid of an electroplating bath, the
- 22 improvement which comprises said anode being closely
- 23 spaced from said cathode, said anode including a wire mesh
- 24 (74) defining a plurality of openings (72) which are
- 25 dimensioned to permit substantially uniform electroplate
- 26 ion transfer onto said cathode, and means (46) for
- 27 controllably circulating said fluid of said bath.
- 28 4. In an apparatus according to claim 3, the
- 29 improvement characterized by one or more of the following
- 30 features:
- 31 (a) said mesh (74) has a grid-like
- 32 configuration;
- 33 (b) said circulating means comprises at least
- 34 one nozzle means (44 . . .) and electromotive means for
- 35 controllably moving said nozzle means;

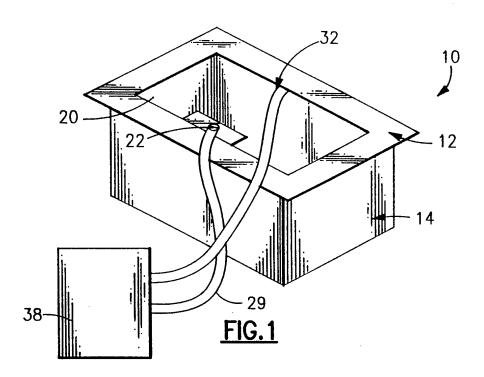
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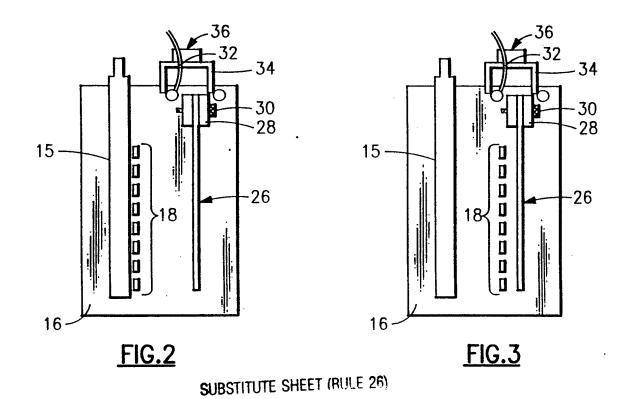
1 (c) said circulating means preferably further
2 comprises a programmable controller device (46) for
3 permitting predetermined motion of said nozzle means; and
4 (d) said cathode comprises a conventional resist
5 pattern disposed thereon, which pattern is adjusted to aid
6 in establishing substantially uniform electroplate ion

- 7 transfer to said cathode.
 8 5. In a process for electroplating a target cathode
 9 using an apparatus including an anode electrode having an
 10 electroactive surface in contact with electrolytic fluid
 11 of an electroplating bath, the improvement which comprises
- 12 placing at least one electrically non-conductive apertured
- 13 mask in direct contact with and covering said cathode at
- 14 least in part whereby to direct electric current through
- 15 the electroplating solution in a controlled manner onto
- 16 the cathode, placing said anode in direct contact with
- 17 said mask on said cathode, and controllably circulating
- 18 said fluid of said bath so as to permit substantially
- 19 uniform electroplating ion transfer onto said cathode.
- 20 6. In a process for electroplating according to 21 claim 5, the improvement characterized by one or more of 22 the following features:
- (a) said fluid circulation is accomplished, at least partially, by directing flow of said fluid through at least one nozzle means, preferably by moving said
- 26 nozzle means according to a predetermined pattern;
- (b) said fluid circulation is accomplished, at least partially, by directing flow of said fluid through at a plurality of nozzle means, preferably by moving said nozzle means according to a predetermined pattern.
- 7. In a process for electroplating a target cathode using an apparatus including an anode electrode having an electroactive surface in contact with electrolytic fluid of an electroplating bath, the improvement which comprises forming said anode so as to include a wire mesh defining a plurality of openings which are dimensioned to permit

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- l substantially uniform electroplating ion transfer onto
- 2 said cathode, placing said anode in close proximity to
- 3 said cathode, and controllably circulating said fluid in
- 4 said bath.
- 5 8. In a process according to claim 7, the
- 6 improvement characterized by one or more of the following
- 7 features:
- 8 (a) said mesh has a grid-like configuration;
- 9 (b) said circulation of said fluid is
- 10 accomplished, at least in part, by directing said fluid
- ll through at least one nozzle means, preferably by moving
- 12 said nozzle means in said bath, preferably wherein said
- 13 movement of said nozzle means is predetermined;
- 14 (c) further comprising adjusting formation of a
- 15 conventional resist pattern disposed upon said cathode so
- 16 as to aid said at least one mask in establishing
- 17 substantially uniform electroplate ion transfer to said
- 18 cathode; and
- 19 (d) further comprising adjusting formation of a
- 20 conventional resist pattern disposed upon said cathode so
- 21 as to aid said at least one mask in establishing
- 22 substantially uniform electroplate ion transfer to said
- 23 cathode.





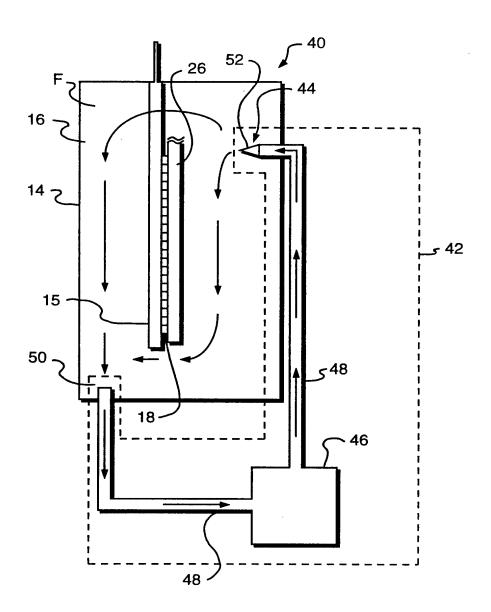


FIG. 4
SUBSTITUTE SHEET (RULE 26)

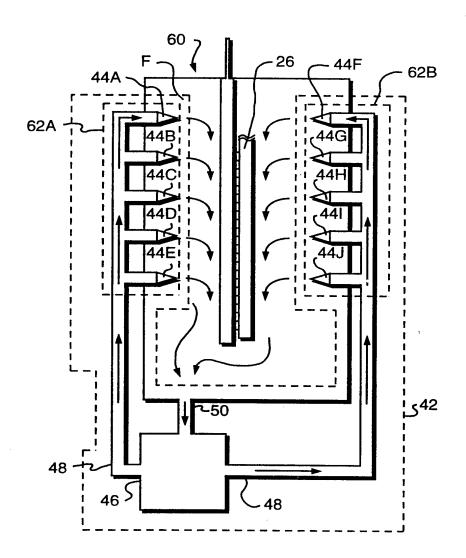


FIG. 5
SUBSTITUTE SHEET (RULE 26)

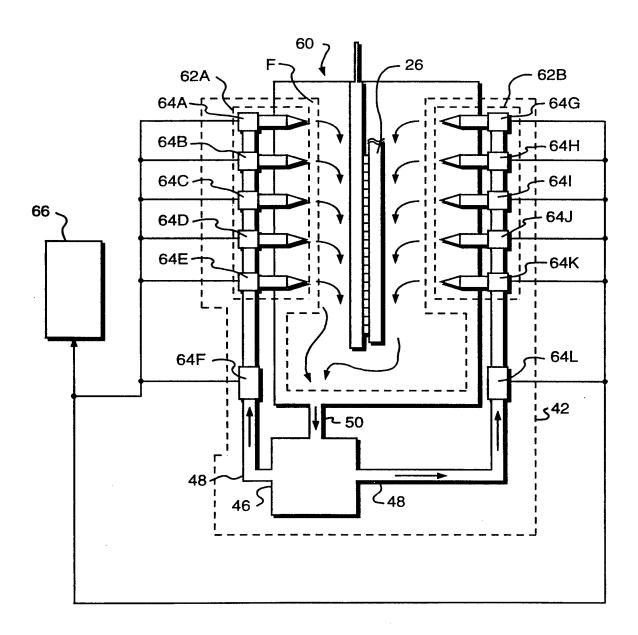


FIG. 6

SUBSTITUTE SHEET (RULE 26).

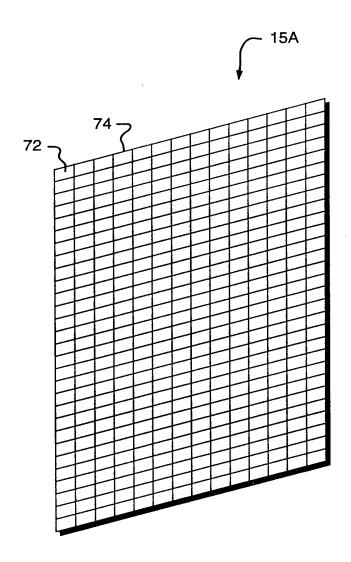


FIG. 7

INTERNATIONAL SEARCH REPORT

International application No. PCT/US95/01141

A. CLASSIFICATION OF SUBJECT MATTER IPC(6) :C25D 5/00, 5/02, 17/12 US CL :204/224R; 205/96 According to International Patent Classification (IPC) or to both national classification and IPC						
B. FIELDS SEARCHED						
Minimum d	ocumentation searched (classification system followe	d by classification symbols)				
U.S. :	U.S. : 204/224R, 237; 205/96, 118, 125, 126, 135					
Documenta	tion searched other than minimum documentation to th	e extent that such documents are included	in the fields searched			
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C. DOC	UMENTS CONSIDERED TO BE RELEVANT					
Category*	Citation of document, with indication, where a	ppropriate, of the relevant passages	Relevant to claim No.			
Υ	US, A, 3,008,892 (OWEN) 14 No lines 1-19, figures 1-3.	ovember 1961, column 2,	1, 2, 5, 6			
Y	US, A, 3,503,856 (BLACKMORE) : lines 59-64, figures 1 and 2.	31 March 1970, column 2,	1-8			
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X	US, A, 4,220,506 (SKURKISS ET column 3, lines 20-26, figures 1 a		3, 4, 7, 8			
X	US, A, 4,394,241 (SCANLON) 1 lines 8-60, figures 3 and 4.	19 July 1983, column 4,	3, 4, 7, 8			
X Further documents are listed in the continuation of Box C. See patent family annex.						
"A" doc	Special estegories of cited documents: "T" later document published after the international filing date or priority date and not in conflict with the application but cited to understand the principle or theory underlying the invention					
"E" car	tier document published on or after the international filing date	"X" document of particular relevance; the considered novel or cannot be consider when the document is taken alone	e claimed invention cannot be red to involve an inventive step			
cité spe	nd to establish the publication date of another citation or other cital reason (as specified)	"Y" document of particular relevance; the considered to involve an inventive	step when the document is			
me	ans	combined with one or more other such being obvious to a person skilled in th	e art			
the priority date claimed document member of the same patent family						
12 JUNE		Date of mailing of the international sea 0.5 JUL 1995	ren report			
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INTERNATIONAL SEARCH REPORT

International application No. PCT/US95/01141

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